



News Release: Leading Wireless Components Manufacturer Purchases Plasma-Therm VERSALINE PECVD System

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July 15, 2010

St. Petersburg, FL – A leading global wireless components manufacturer has chosen to add a Plasma-Therm VERSALINE® PECVD/HDPCVD system to its manufacturing assembly. The U.S. based manufacturer is enhancing its fab facility in preparation for the projected ramp up in the wireless industry.

This VERSALINE system is a multi-chamber configuration with a high-density plasma deposition source module and a standard PECVD module. The versatile system is built to handle two independent cassette chambers and up to four process modules. VERSALINE's platform has a foundation that is built to easily manage composition and stress control and monitor film thickness as well as other characteristics of quality, accurately with repeatable results.

“The flexible configuration options of VERSALINE's platform allow equipment users to find the custom results they demand at a low cost of ownership. From research laboratories to high volume production environments, Plasma-Therm stands by our tools and our ability to provide custom solutions to specialty market challenges,” stated Ed Ostan, executive vice president of sales & marketing at Plasma-Therm.

Plasma-Therm, founded in 1974, is a supplier of advanced plasma process equipment offering both dry etch & PECVD technologies that caters to various specialty markets including photomask, solid state lighting, thin film head and compound semiconductor. To meet the diverse needs of our global customer base, Plasma-Therm has sales, service and spares locations throughout North America, Europe and Asia-Pacific. For more information, visit us at www.plasmatherm.com.

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